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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

MIKHAYLICH et al.

Application No: 10/766,733

Filed: January 27, 2004

For: METHOD AND SYSTEM FOR CLEANING
A SEMICONDUCTOR WAFER

) Attorney Docket No: LAM1P108D

) Examiner: MARKOFF, A.

) Group Art Unit: 1746

) Date: April 12, 2006

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on April 12, 2006.

Signed:

Melinda M. Ward

AMENDMENT

Mail Stop AF
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is in response to a Final Office Action dated March 8, 2006,

term to respond extends to May 8, 2006. Please enter this Amendment and remarks.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

Do not enter
[Signature]